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APPLICANTS

Yoshihiko Nemoto, Tokyo, JAPAN;

Tomonori Fujii, Tokyo, JAPAN;

Masahiro Sunohara, Nagano, JAPAN; Tomotoshi Sato, Osaka, JAPAN;

** CONTINUING DATA ***** *None S.W.S.*** FOREIGN APPLICATIONS ***** *S.W.S.*
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>S.W.S.</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 1
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ADDRESS

McDermott, Will & Emery
600 13th Street, N.W.
Washington, DC
20005-3096

TITLE

Method of manufacturing a semiconductor device with penetration electrodes that protrude from a rear side of a substrate formed by thinning the substrate

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